



JUL 21 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Sup., et al.

Serial No.: 09/645,690

Confirmation No.: 4428

Filed: August 24, 2000

For: Cu CMP Polishing Pad
Cleaning

MAIL STOP DD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PATENT

Group Art Unit: 1746

Examiner: Winter, Gentle E.

CERTIFICATE OF MAILING
37 CFR 1.8

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

07/23/2003 JBALINAN 00000085 200782 09645690

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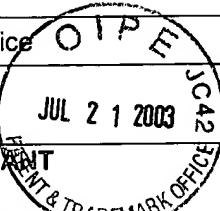
If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/APPM/4215.Y1/BTP.

Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/4215.Y1/CMP /CMP/RKK	Serial No. 09/645,690
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Sun, et al.	Confirmation No.: 4428
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)		Filing Date August 24, 2000	Group 1746
	Examiner Winger, Gentle E.		

**U.S. Patent Documents**

*Examiner Initial	Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
A1						
A2						
A3						
A4						
A5						
A6						
A7						
A8						
A9						
A10						
A11						
A12						
A13						
A14						
A15						

Foreign Patent Documents

*Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						YES	NO
B1	00/59029	10/05/00	WO	H01L	21/60	<input type="checkbox"/>	<input type="checkbox"/>
B2	0 913 442 A2	05/06/99	EP	C09G	1/02	<input type="checkbox"/>	<input type="checkbox"/>
B3	0 859 407 A2	08/19/98	EP	H01L	21/768	<input type="checkbox"/>	<input type="checkbox"/>
B4	0 620 293 A1	10/19/94	EP	C23F	1/18	<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial	Including Author, Title, Date, Pertinent Pages, Etc.		
C1	Brusic, et al. "Copper Corrosion With and Without Inhibitors," J. Electrochem. Soc., Vol 138, No. 8, August 1991		
C2			
C3			

Examiner	Date Considered
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.	